PATENT

Attorney D cket No. 081468-0306524 Client Reference: P-0381.020-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Joeri LOF,

Antonius T. A. M. DERKSEN, Christiaan A. HOOGENDAM, Aleksey KOLESNYCHENKO,

Erik R. LOOPSTRA,

Theodorus M. MODDERMAN, Johannes C. H. MULKENS, Roelof A. S. RITSEMA,

Klaus SIMON,

Joannes T. DE SMIT, Alexander STRAAIJER, Bob STREEFKERK, and Helmar VAN SANTEN

Lithographic Apparatus and Device Manufacturing Method

Application No.:

Not Yet Assigned

Confirmation

Not Yet Assigned

No:

Filed:

For:

November 12, 2003

Group No.:

Not Yet Assigned

Examiner

Not Yet Assigned

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

APPLICATION DATA SHEET 37 C.F.R. § 1.76

BIBLIOGRAPHIC DATA

1. Applicant information

First applicant: Joeri LOF

Citizenship: Dutch

Residence: Graaf Adolfstraat 6, Eindhoven 5616 BW, THE NETHERLANDS

Second applicant: Antonius T. A. M. DERKSEN

Citizenship: Dutch

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Third applicant: Christiaan A. HOOGENDAM

Citizenship: Dutch

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Fourth applicant: Aleksey KOLESNYCHENKO

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Fifth applicant: Erik R. LOOPSTRA

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Sixth applicant: Theodorus M. MODDERMAN

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Seventh applicant: Johannes C. H. MULKENS

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Eighth applicant: Roelof A. S. RITSEMA

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Tenth applicant: Joannes T. DE SMIT

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Eleventh applicant: Alexander STRAAIJER

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Twelfth applicant: Bob STREEFKERK

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Thirteenth applicant: Helmar VAN SANTEN

Citizenship: Dutch

Residence: Laagte Kadijk 17E, Amsterdam 1018 BB, THE NETHERLANDS

2. Correspondence information

Correspondence for this application should be addressed as follows:

Customer No.: 00909

3. Application information

Title of Invention: Lithographic Apparatus and Device Manufacturing Method

Docket number assigned to this application: 081468-0306524

Suggested Classification:

Class:

Subclass:

Technology Center to which subject matter is assigned:

Total number of drawing sheets: 7

Type of application:

Utility

Application is to be published. Suggested drawing figure for publication: FIGURE 2

Secrecy order under § 5.2:

This application does not disclose subject matter of an application which is under a secrecy order pursuant to § 5.2.

4. Representative information

The following have a power of attorney or authorization of agent in this application:

Customer No.: 00909

5. Foreign priority information

Foreign priority is claimed for this application as follows:

Country: EUROPE

Application No.: 02257822.3 Filing Date: November 12, 2002

Country: EUROPE

Application No.: 03252955.4 Filing Date: May 13, 2003

6. Assignee information

The assignee(s) of this application is/are:

ASML Netherlands B.V.

De Run 1110, Veldhoven, 5503 LA, The Netherlands

Extent of interest of assignee in application: ENTIRE RIGHT, TITLE AND INTEREST

Date: November 12, 2003

Jack S. Barufka Reg. No.: 37087

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